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APPLICATION NO	. F	ILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO
10/679,816	0/679,816 10/06/2003		Robert Bristol	ITL.1023US (P16710)	3390
21906	7590	03/23/2006		EXAMINER .	
TROP PR 8554 KAT		•	DUDA, KATHLEEN		
SUITE 100		71		ART UNIT	PAPER NUMBER
HOUSTON	N, TX 770	24	1756		

DATE MAILED: 03/23/2006

Please find below and/or attached an Office communication concerning this application or proceeding.

		Application No.	Applicant(s)					
		10/679,816	BRISTOL ET AL.					
	Office Action Summary	Examiner	Art Unit					
		Kathleen Duda	1756					
The MAILING DATE of this communication appears on the cover sheet with the correspondence address Period for Reply								
WHIC - Exter after - If NO - Failu Any r	ORTENED STATUTORY PERIOD FOR REPLEHEVER IS LONGER, FROM THE MAILING DOSIONS of time may be available under the provisions of 37 CFR 1.1 SIX (6) MONTHS from the mailing date of this communication. Period for reply is specified above, the maximum statutory period the to reply within the set or extended period for reply will, by statute eply received by the Office later than three months after the mailined patent term adjustment. See 37 CFR 1.704(b).	ATE OF THIS COMMUNICATION 136(a). In no event, however, may a reply be time will apply and will expire SIX (6) MONTHS from the cause the application to become ABANDONEI	J. nely filed the mailing date of this communication. D (35 U.S.C. § 133).					
Status								
1)⊠	Responsive to communication(s) filed on 27 F	ebruary 2006.						
2a) <u></u> □	This action is FINAL . 2b)⊠ This action is non-final.							
3)	Since this application is in condition for allowance except for formal matters, prosecution as to the merits is							
	closed in accordance with the practice under Ex parte Quayle, 1935 C.D. 11, 453 O.G. 213.							
Dispositi	on of Claims							
5)□ 6)⊠ 7)□	Claim(s) <u>1-40</u> is/are pending in the application 4a) Of the above claim(s) <u>34-40</u> is/are withdraw Claim(s) is/are allowed. Claim(s) <u>1-33</u> is/are rejected. Claim(s) is/are objected to. Claim(s) are subject to restriction and/or	wn from consideration.						
Applicati	on Papers							
10)	The specification is objected to by the Examine The drawing(s) filed on is/are: a) acc Applicant may not request that any objection to the Replacement drawing sheet(s) including the correct The oath or declaration is objected to by the Example 2.	cepted or b) objected to by the E drawing(s) be held in abeyance. See tion is required if the drawing(s) is obj	e 37 CFR 1.85(a). ected to. See 37 CFR 1.121(d).					
Priority u	ınder 35 U.S.C. § 119							
 12) Acknowledgment is made of a claim for foreign priority under 35 U.S.C. § 119(a)-(d) or (f). a) All b) Some * c) None of: 1. Certified copies of the priority documents have been received. 2. Certified copies of the priority documents have been received in Application No. 3. Copies of the certified copies of the priority documents have been received in this National Stage application from the International Bureau (PCT Rule 17.2(a)). * See the attached detailed Office action for a list of the certified copies not received. 								
2) Notice	e of References Cited (PTO-892) e of Draftsperson's Patent Drawing Review (PTO-948)	4) Interview Summary Paper No(s)/Mail Da	ite					
3) Information Disclosure Statement(s) (PTO-1449 or PTO/SB/08) Paper No(s)/Mail Date 01022004, 12122005. 5) Notice of Informal Patent Application (PTO-152) 6) Other:								

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DETAILED ACTION

1. Claims 1-40 are pending in this application.

Election/Restrictions

- 2. Applicant's election of Group I, claims 1-33 in the reply filed on 2/27/2006 is acknowledged. Because applicant did not distinctly and specifically point out the supposed errors in the restriction requirement, the election has been treated as an election without traverse (MPEP § 818.03(a)).
- 3. Claims 34-40 are withdrawn from further consideration pursuant to 37 CFR 1.142(b) as being drawn to a nonelected invention, there being no allowable generic or linking claim. Election was made **without** traverse in the reply filed on 2/27/2006.

Claim Rejections - 35 USC § 102

4. The following is a quotation of the appropriate paragraphs of 35 U.S.C. 102 that form the basis for the rejections under this section made in this Office action:

A person shall be entitled to a patent unless -

(b) the invention was patented or described in a printed publication in this or a foreign country or in public use or on sale in this country, more than one year prior to the date of application for patent in the United States.

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(e) the invention was described in (1) an application for patent, published under section 122(b), by another filed in the United States before the invention by the applicant for patent or (2) a patent granted on an application for patent by another filed in the United States before the invention by the applicant for patent, except that an international application filed under the treaty defined in section 351(a) shall have the effects for purposes of this subsection of an application filed in the United States only if the international application designated the United States and was published under Article 21(2) of such treaty in the English language.

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5. Claims 1-10 are rejected under 35 U.S.C. 102(b) as being anticipated by JP 10-106930.

JP 10-106930 teaches a process of exposing an unexposed resist film to an electric field. It is taught that the electric field provides orientation within the film. The film is then exposed to radiation. (See abstract).

6. Claims 1-10 are rejected under 35 U.S.C. 102(e) as being anticipated by Lin (US 2004/0265739).

Lin teaches a process of forming a photoresist pattern. Paragraph 0024 teaches that the photoresist film is treated with an electric field to orient the polymer. It is taught that the photoresist is then exposed after adjusting the orientation (see paragraph 0026).

7. Claims 11-19 are rejected under 35 U.S.C. 102(e) as being anticipated by Cheng (US 2003/0008246).

Cheng teaches a process of enhancing resist sensitivity using an electric field. Figure 2 depicts the wafer with conductive coating both above

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and below the photoresist layer. It is taught that the wafer is heated while the electric field is applied (see examples).

8. Claims 20-24 are rejected under 35 U.S.C. 102(b) as being anticipated by JP 63-244622.

JP 63-244622 teaches a process of forming a semiconductor device using a photoresist film. The photoresist is exposed to an electric field during photolithographic processing (see abstract and Figure).

9. Claims 25-29 are rejected under 35 U.S.C. 102(e) as being anticipated by Nishi (US 2003/0032302).

Nishi teaches a process of forming a photoresist pattern. An electric field is applied while the wafer is being baked (see claim 26).

10. Claims 30-33 are rejected under 35 U.S.C. 102(b) as being anticipated by Templeton (US 2002/0046703).

Templeton teaches a photoresist development process. Paragraph 0045 and Figures 6 and 9 teach that an electric field is applied during development of the photoresist.

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Conclusion

11. Any inquiry concerning this communication should be directed to Examiner K. Duda at (571) 272-1383. Official FAX communications should be sent to (571) 273-8300.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Mark Huff, can be reached at 571-272-1385.

Information regarding the status of an application may be obtained from the Patent Application Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

Kathleen Duda Primary Examiner Art Unit 1756